



Attorney Docket No. 0756-1986

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)	Group Art Unit: 2826
Yasuhiko TAKEMURA	)	Examiner: A. Sefer
Serial No. 09/342,235	)	<u>CERTIFICATE OF MAILING</u>
Filed: June 29, 1999	)	I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on September 22, 2003.
For: SEMICONDUCTOR DEVICE HAVING	)	
AT LEAST FIRST AND SECOND	)	
THIN FILM TRANSISTORS	)	<u>Rose Fickel</u>

RESPONSE

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The Official Action mailed May 20, 2003, has been received and its contents carefully noted. Filed concurrently herewith is a *Request for One Month Extension of Time*, which extends the shortened statutory period for response to September 20, 2003. Accordingly, the Applicant respectfully submits that this response is being timely filed.

Disclosure Statements filed on June 29, 1999, October 31, 2000, June 4, 2001, March 7, 2002, May 7, 2002, November 8, 2002, and February 24, 2003. However, the Applicant has not received acknowledgment of the IDS filed on October 25, 2000. Also, the Applicants note the partial consideration of the IDS filed on November 30, 2001 (see Paper No. 19). Specifically, it appears that the Examiner inadvertently overlooked the citation of U.S. Patent No. 5,250,931 to Misawa et al. The Applicants respectfully request that the Examiner provide an initialed copy of the Form PTO-1449 evidencing consideration of the IDS's filed October 25, 2000, and November 30, 2001.

RECEIVED  
SEP 30 2003  
TECHNOLOGY CENTER 2826